



AF 2815  
X IFW

Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER, LASER  
IRRADIATION APPARATUS,  
SEMICONDUCTOR DEVICE, AND  
METHOD OF FABRICATING THE  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2815

) Examiner: J. Diaz

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is  
being deposited with the United States Postal  
Service with sufficient postage as First Class  
Mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on

5.10.2004

Adile M. Stamps

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated January 9, 2004, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.